



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 016778/0437

Applicant: Yukio MORISHIGE et al.

Title: METHOD AND DEVICE FOR CORRECTING PATTERN
FILM ON A SEMICONDUCTOR SUBSTRATE

Application No.: 09/981,712

Filing Date: October 19, 2001

Examiner: Hassanzadeh, Parvis

Art Unit: 1763

AMENDMENT AND REPLY UNDER 37 C.F.R. 1.111

Mail Stop NON-FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated January 6, 2004, concerning the above-referenced patent application.

Amendments to the Specification begin on page 2 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this document.

Remarks/Arguments begin on page 10 of this document.

Please amend the application as follows: